



PTO/SB/08A (10-01)

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Substitute for form 1449A/PTO		Complete If Known	
		Application Number	10/632165
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Filing Date	7/31/2003
		First Named Inventor	Wan-Thai Hsu
		Art Unit	2817
		Examiner Name	
		Attorney Docket Number	436-001US
Sheet	-1-	of	-2-

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
[Signature]	AA	US- 6,249,073	6/19/2001	Nguyen	
	AB	US-			
	AC	US-			
	AD	US-			
	AE	US-			
		US-			
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FOREIGN PATENT DOCUMENTS						
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		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
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Examiner Signature	[Signature]	Date Considered	11/22/2004
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		Group Art Unit	2817		
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Sheet	-2-	of	-2-	Attorney Docket Number	436-001US

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
<i>WTH</i>	CA	W.-T. HSU, J.R. CLARK, AND C.T.-C. NGUYEN, Q-optimized lateral free-free beam micromechanical resonators, Digest of Technical Papers, June 10-14, 2001, 11th Int. Conf. on Solid-State Sensors & Actuators (Transducers'01), Munich, Germany	T
	CB	K. WANG, Y. YU, A.-C. WONG AND C.T.-C. NGUYEN, VHF free-free beam high-Q micromechanical resonators, Technical Digest, Jan. 17-21, 1999, 12th International IEEE Electro Mechanical Systems Conf Orlando, Florida	T
	CC	C.T.-C. NGUYEN, Transceiver front-end architectures using vibrating micromechanical signal processors (invited), Dig. of Papers, Sept. 12-14, 2001, Topical Meeting on Silicon Monolithic Integrated Circuits in RF Systems	T
	CD	C.T.-C. NGUYEN, Frequency-selective MEMS for miniaturized low-power communication devices (invited), IEEE Trans. Microwave Theory Tech., Aug 1999, Vol. 47, No. 8	T

Examiner Signature	<i>Patricia Wamsley</i>	Date Considered	11/22/2004
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